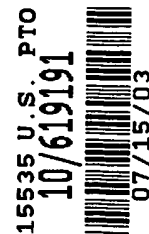




UTILITY PATENT APPLICATION  
UNDER 37 CFR 1.53(b)



Mail Stop Utility  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Case Docket No. 60188-578

Sir:

Transmitted herewith for filing is the patent application of:

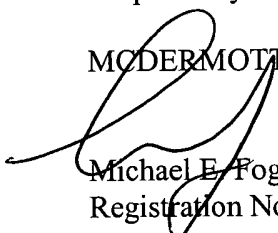
INVENTOR: **Shinichi IMAI, Masaki TAGUCHI**  
FOR: **SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION  
APPARATUS**

Enclosed are:

- ☒ 47 pages of specification, claims, abstract.
- ☐ Declaration and Power of Attorney.
- ☒ Priority Claimed - **Japanese Patent Application No. 2002-205667**
- ☐ Certified copy of \_\_\_\_\_
- ☒ 15 sheets of formal drawing.
- ☐ An assignment of the invention to \_\_\_\_\_  
and the assignment recordation fee.
- ☐ An associate power of attorney.
- ☐ Information Disclosure Statement, Form PTO-1449 and reference.
- ☒ Return Receipt Postcard

Respectfully submitted,

MODERMOTT, WILL & EMERY

  
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